

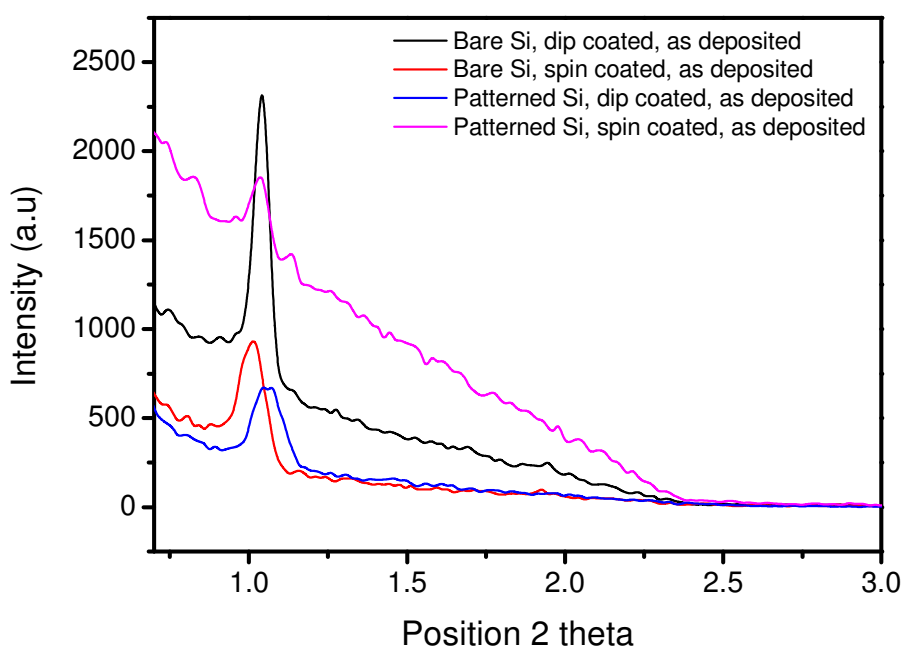
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# Pore Directionality and Correlation Lengths of Mesoporous Silica Channels Aligned by Physical Epitaxy

Ciara T. Bolger<sup>†,ϕ</sup>, Richard A. Farrell<sup>†,ϕ</sup>, Gareth M. Hughes<sup>§</sup>, Michael A. Morris<sup>†,ϕ</sup>, Nikolay Petkov<sup>‡,\*</sup> and Justin D. Holmes<sup>†,ϕ\*</sup>



**Figure S1** Reflective X-ray Diffraction patterns of spin- and dip-coated mesoporous films on bare and patterned silicon substrates